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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				<i>Complete if Known</i>	
				Application Number	10/665026
		Filing Date			
		First Named Inventor	Shahab Khandan		
		Art Unit	2829		
		Examiner Name	ZARAKJE		
Sheet	2	of	2	Attorney Docket Number	4887P327D2

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
AK		J.G. Jonesa, et al., "In-situ control of chemical vapor deposition for fiber coating," Abstract, Materials and Manufacturing Directorate, Air Force Research Laboratory, Wright-Patterson AFB, OH 45433, December 1997	
AK		Z. Yu, et al., "Influence of oxygen and nitrogen on the growth of hot-filament chemical vapor deposited diamond films," Abstract, Thin Solid Films 1999, 342:1-2:74-82	

Examiner Signature		Date Considered	1/26/05
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

¹Applicant's unique citation designation number. ²Applicant is to place a check mark here if English language Translation is attached.

Based on PTO/SB/08B (08-03) as modified by Blakely, Sotokoff, Taylor & Zafman (wlr) 08/11/2003.
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